

## ***Supporting Information***

**Single silicon-doped CNT as a metal-free electrode for robust nitric oxide reduction utilizing a**

**Lewis base site: An ingenious electronic “Reflux-Feedback” mechanism**

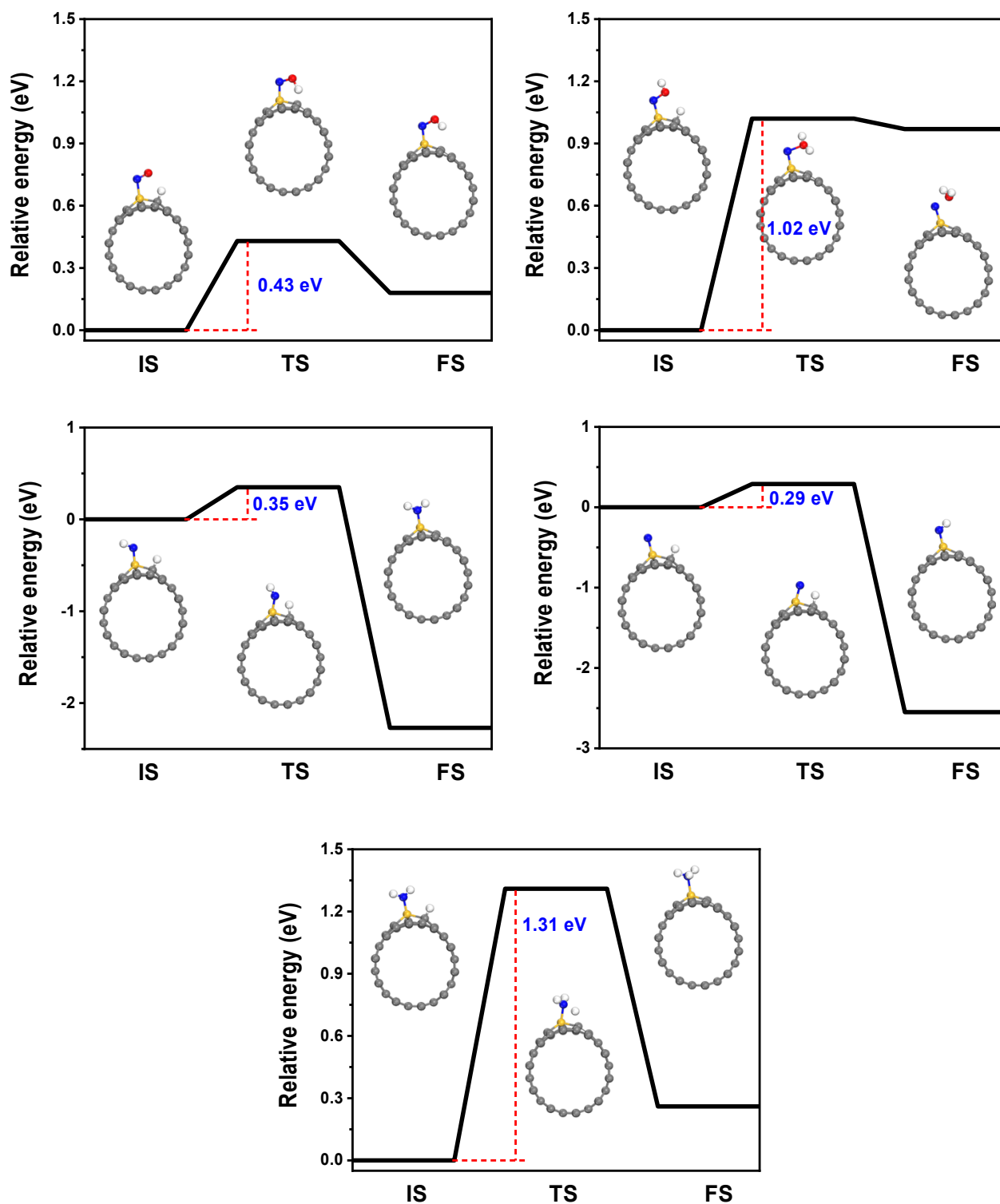
Lei Yang, Jiake Fan, Weihua Zhu\*

*Institute for Computation in Molecular and Materials Science, School of Chemistry and Chemical  
Engineering, Nanjing University of Science and Technology, Nanjing 210094, China*

---

\* Corresponding author. E-mail: zhuwh@njust.edu.cn

**Figure S1.** The transition state search of NORR on Si-CNT(10, 0).



**Table S1.** The adsorption energy of NO with O-end, N-end and side on adsorption modes. (eV)

Systems	O-end	N-end	Side on
Si-G	-0.34	-0.80	
Si-CNT(6, 0)	-0.05	-0.96	
Si-CNT(7, 0)	-0.02	-0.90	
Si-CNT(8, 0)	0.00	-0.89	
Si-CNT(9, 0)	-0.05	-0.85	
Si-CNT(10, 0)	-0.08	-0.83	
Si-CNT(11, 0)	-0.08	-0.83	
Si-CNT(12, 0)	-0.07	-0.81	

**Table S2.** The adsorption free energy changes of NORR on Si-CNT(10, 0) with and without solvent effect. (eV)

	With solvent effect	Without solvent effect
*NO	-0.88	-0.85
*NOH	-0.82	-0.75
*N	-0.67	-0.57
*NH	-2.77	-2.60
*NH <sub>2</sub>	-4.70	-4.90
*NH <sub>3</sub>	-4.48	-4.64
$U_L$	-0.22	-0.25